

EV026159681

#3 5-22-02  
PB

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. .... 09/389,533  
Priority Filing Date ..... September 2, 1999  
Inventor ..... Alan R. Reinberg  
Assignee ..... Micron Technology, Inc.  
Priority Group Art Unit ..... 2823  
Priority Examiner ..... T. Pham  
Attorney's Docket No. .... MI22-1952  
Title: Methods of Forming Capacitors and Resultant Capacitor Structures

11040 U.S. PTO  
10/082594  
02/22/02

INFORMATION DISCLOSURE STATEMENT

References - - See attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

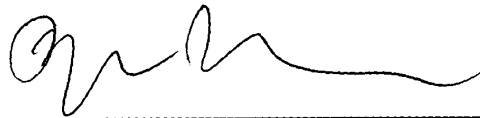
The listed references were cited by, or submitted to, the Office in the parent, co-pending application of the above-identified application. The above-identified application is a continuation application of co-pending application Serial No. 09/389,533, filed September 2, 1999, upon which the above-identified application relies for a priority date under 35 U.S.C. §120. Such prior disclosure is sufficient for the above-identified application as far as copies of the references are concerned. 37 C.F.R. §1.98(d) and MPEP §609(2). As a courtesy, Applicant submits copies of the cited references for review.

Citation of these references is respectfully requested.

Respectfully submitted,

Date:

Feb 22, 2002



Frederick M. Fliegel, Ph.D.  
Reg. No. 36,138

#3

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1952	SERIAL NO.
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Alan R. Reinberg	
				FILING DATE	GROUP 2823

U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
Lee	AA	6,150,211	11/21/00	Zahurak			
Lee	AB	5,981,333	11/09/99	Parekh et al.			
Lee	AC	5,905,280	05/18/99	Liu et al.			
Lee	AD	5,338,700	08/16/94	Dennison et al.			
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS							
	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
	AL						
	AM						
	AN						
	AO						
	AP						

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
	AR		
	AS		
	AT		

EXAMINER <i>Shun Ming Lee</i>	DATE CONSIDERED <i>4/9/03</i>
----------------------------------	----------------------------------

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

